

Surface-functionalized Silica Microsphere Lasers

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Outline

● Introduction

- Background and motivation
- Sol-gel technology and surface functionalization

● Experimental results

- Spatial mode selection
- Analysis for laser operation dynamics
- Pulse and CW operation

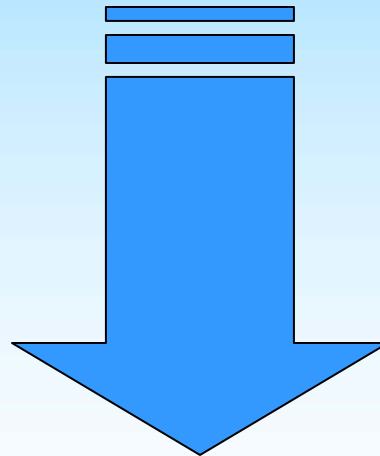
● Summary

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Background for Functionalization

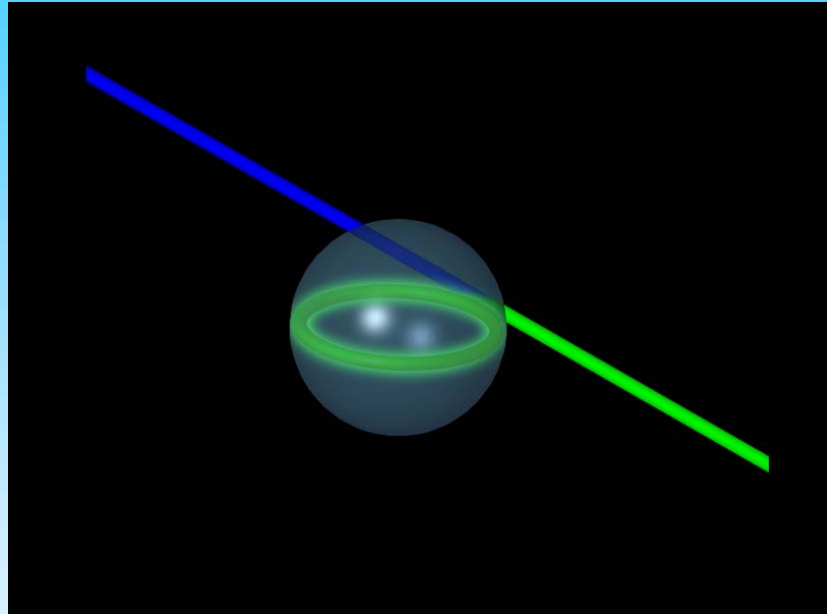
Why surface functionalize the silica microsphere resonator ?



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Whispering Gallery Mode Microsphere Lasers



The resonator modes are strongly confined just within the inside surface by continuous total internal reflection.

- Radial direction: Spherical Bessel
- Polar direction: Associate Legendre Polynomial

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Previous Work on Rare-earth Doped Microsphere Lasers

Very low threshold WGM Nd³⁺ doped silica microsphere lasers (V.Sandoghdar, F. Treussart, J. Hare, V. Lefevre-Seguin, J.M.Ramond, and S. Haroche, Phys. Rev. A 54, 1777(1996))

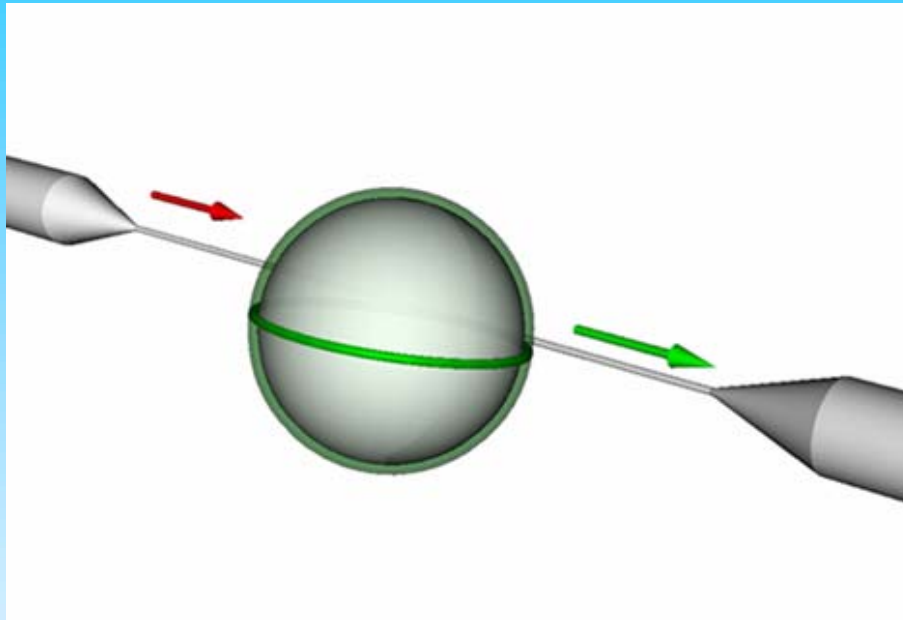
- Threshold: 200 nW**
- Laser output: 150 pW**
- Quantum efficiency: 0.035%**

Low threshold Er³⁺ doped phosphate microsphere lasers (M. Cai, O. Painter, K. J. Vahala and P. C. Sercel, Opt. Lett. 25, 1430 (2000))

- Threshold: 60 μ W**
- Laser output: 3 μ W**
- Quantum efficiency: 2.5% (Improved by taper coupling scheme)**



Motivation



- The WGM's in glass microsphere are confined in the 'film region'
- More flexible because multiple dopants are available
- Investigation of pulsation behavior

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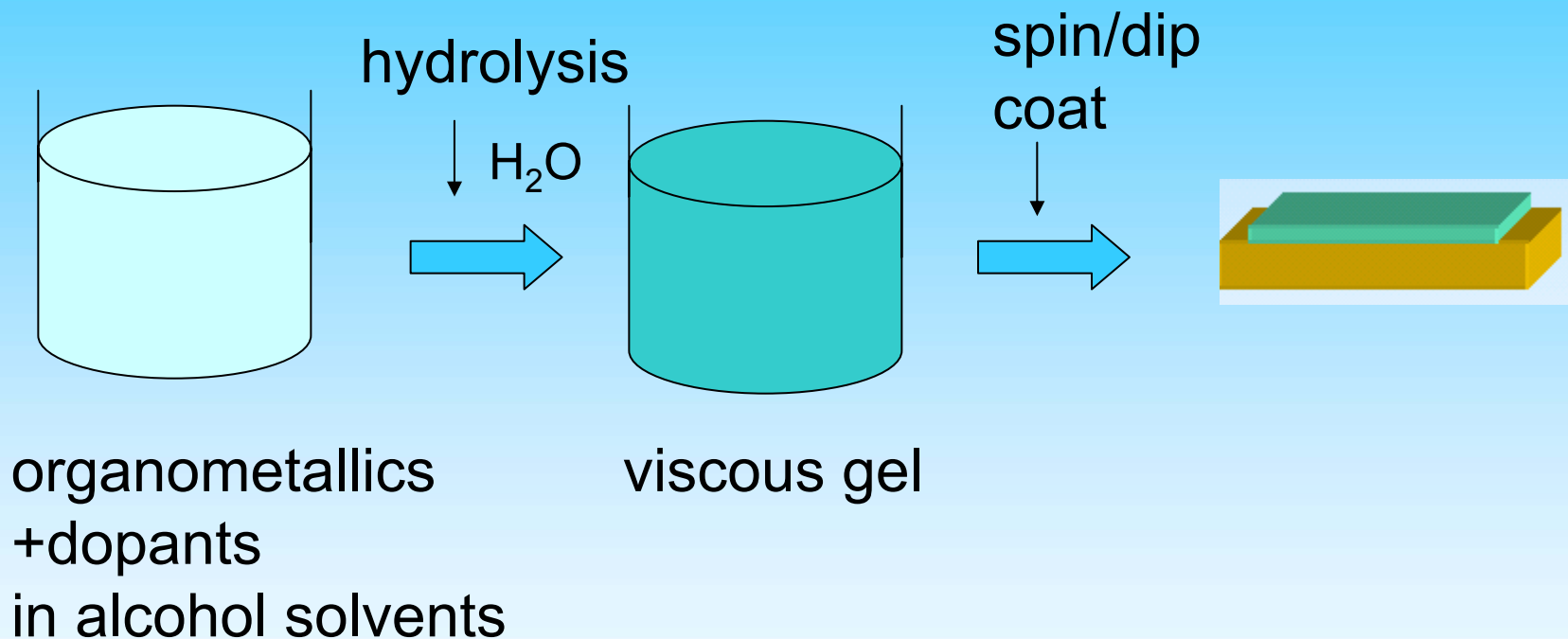


Advantages of Sol-gel Method

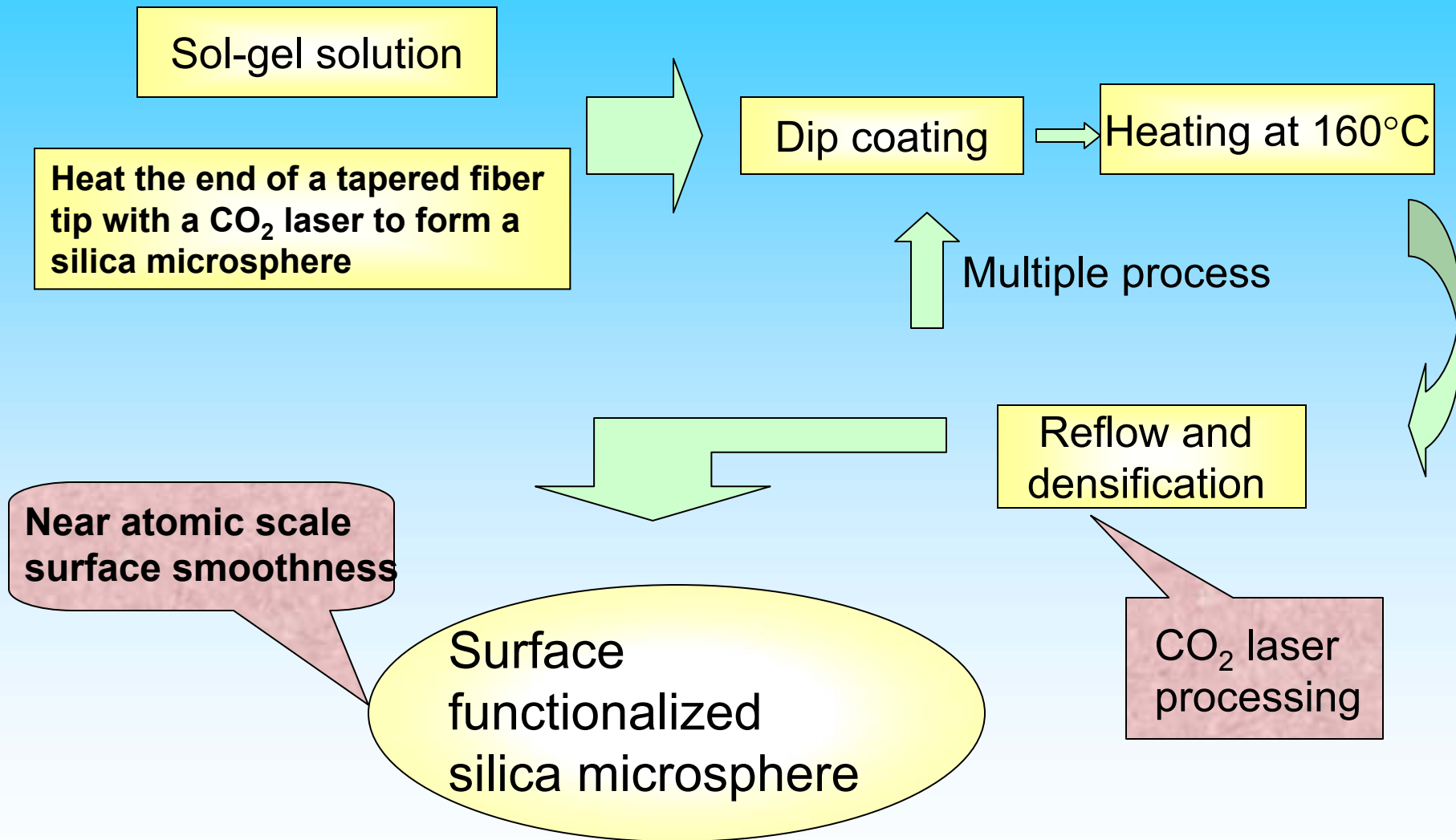
- Involves liquid chemical synthesis of homogeneous materials
- Versatile method to deposit thin films on non-planar surfaces
- Low cost and simple procedure
- Environmentally safe, versus other processes such as chemical vapor deposition (CVD)



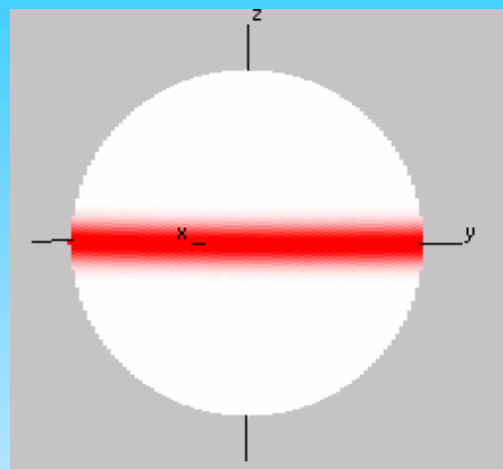
Sol Gel Process



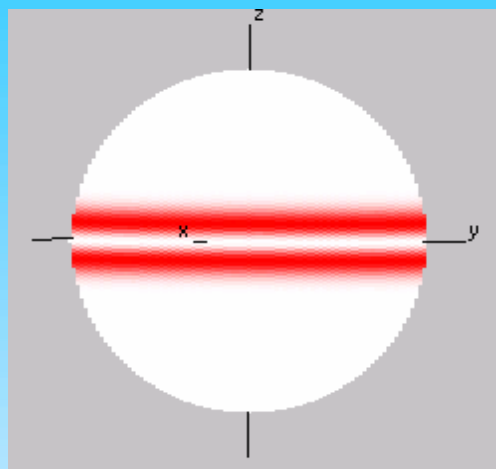
Process Flow



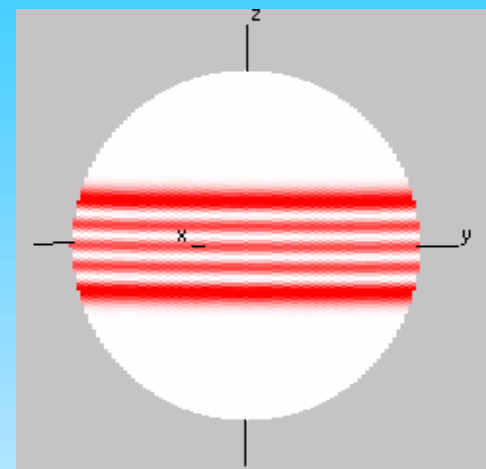
Equatorial WGM's



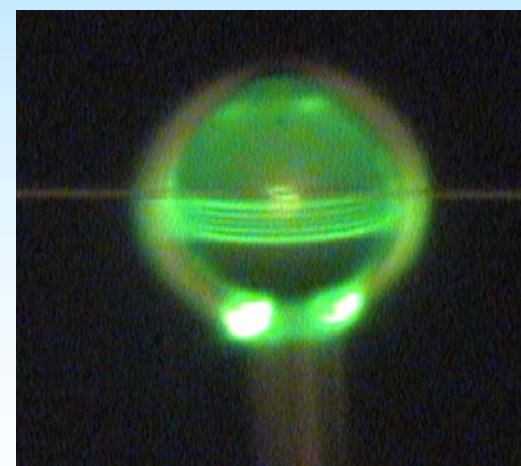
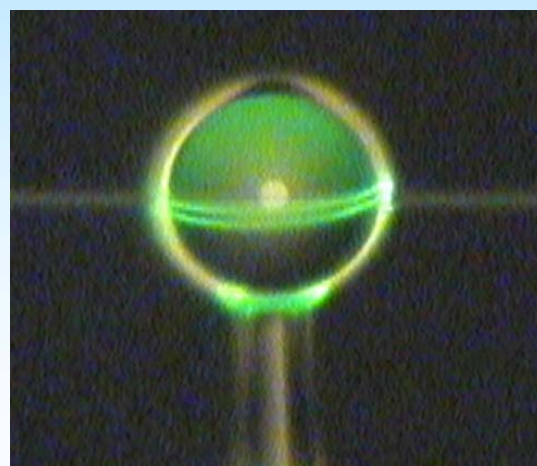
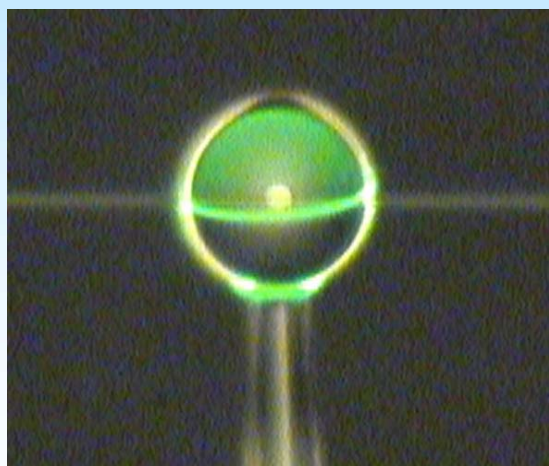
$m=1$



$m=|l-1$



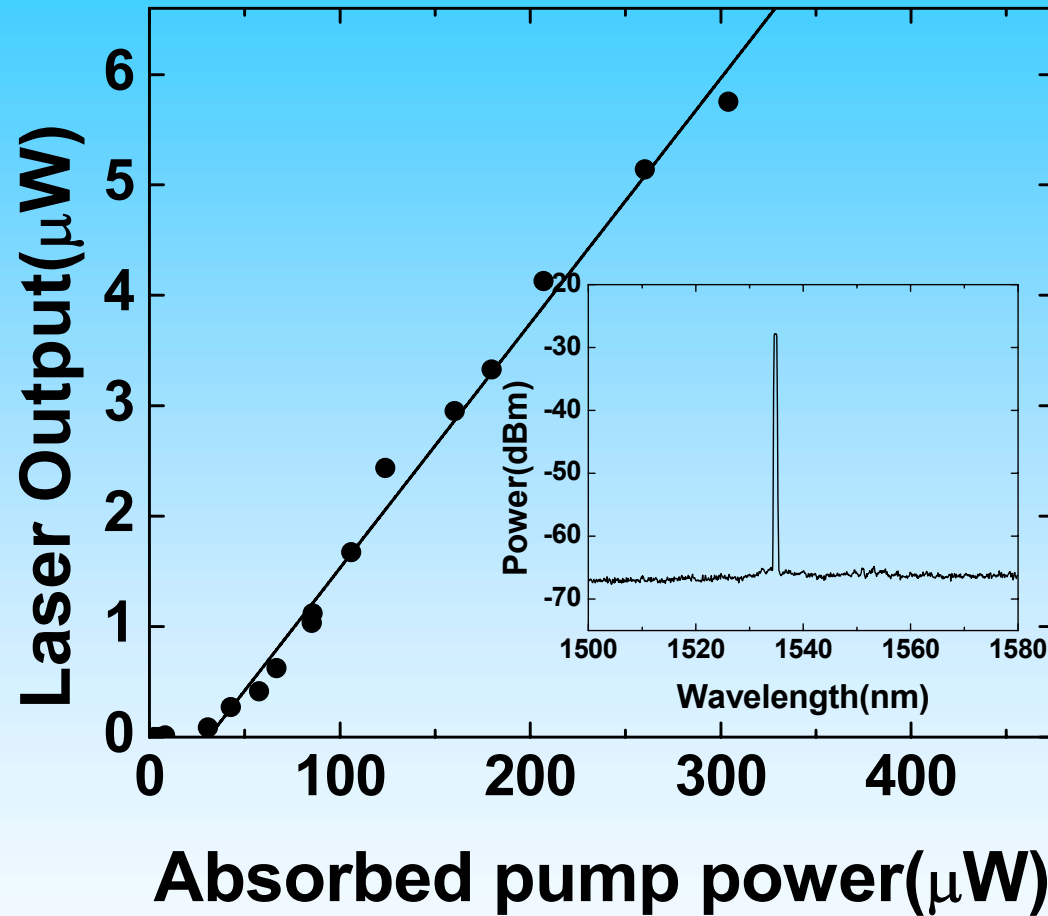
$m=|l-4$



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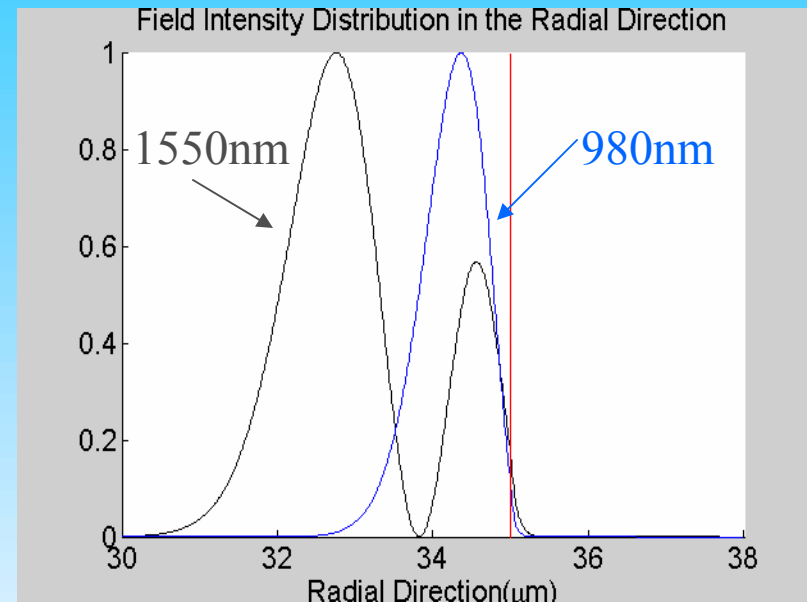
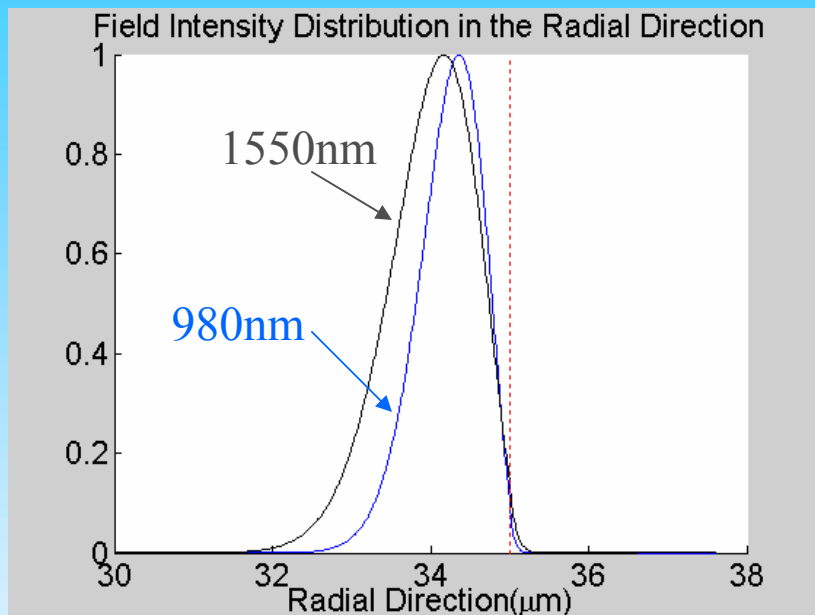
Laser Performance



Contributing factors for low threshold performance:

- Low loss medium
- CO_2 reflow process
- Highly confined mode volume
- Efficient fiber taper coupling scheme

Mode Selection Mechanisms



Overlap of pumping and lasing modes

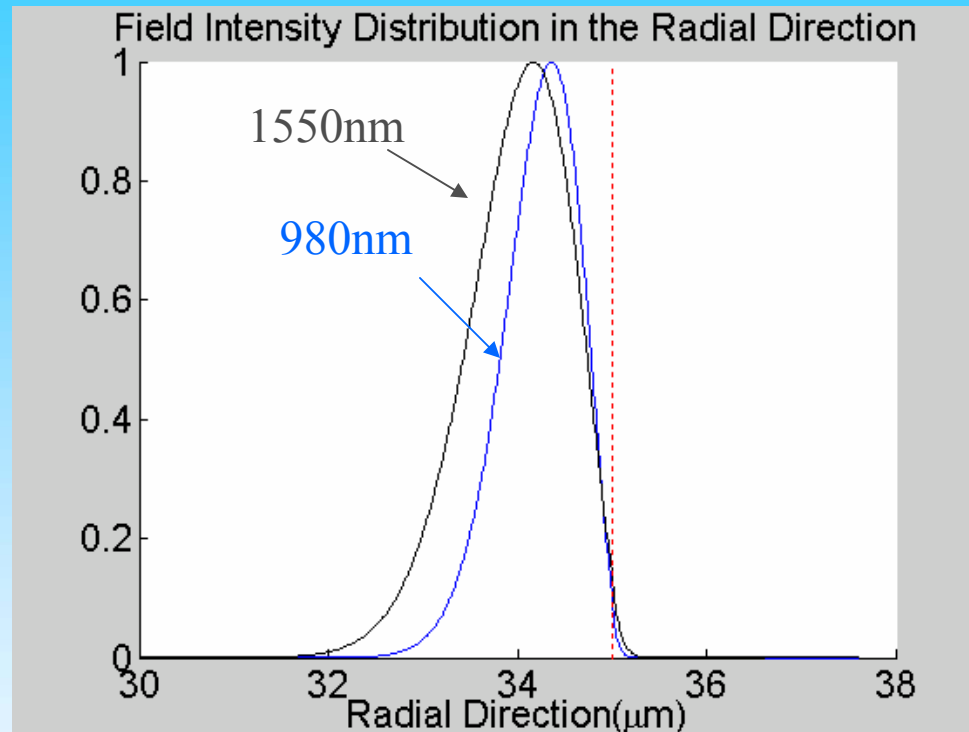


Suppression of higher order radial modes:

- Fundamental radial WGM's have best spatial overlap with fiber taper
- Fundamental radial WGM's have best overlap with active surface region

Similar mode selection mechanism also works for azimuthal WGM's

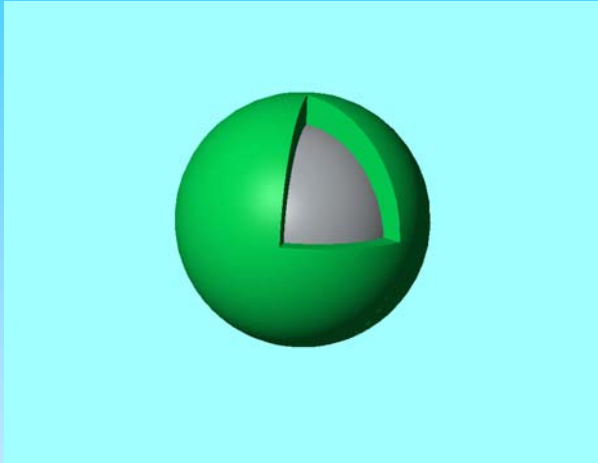
Effect of Film Thickness on Laser Dynamics



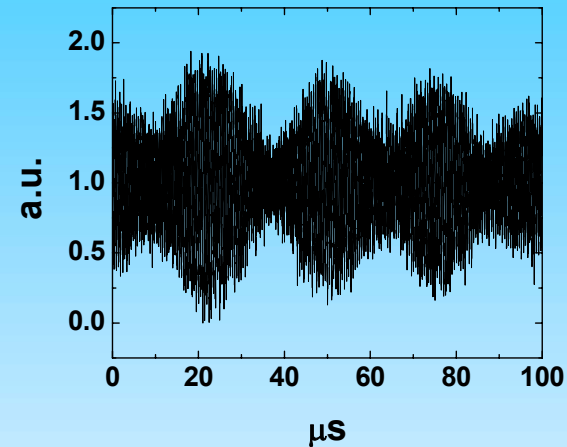
- Un-pumped region works as intracavity saturable absorber and permits pulsation mode generation

CW v.s. PM Operation

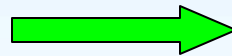
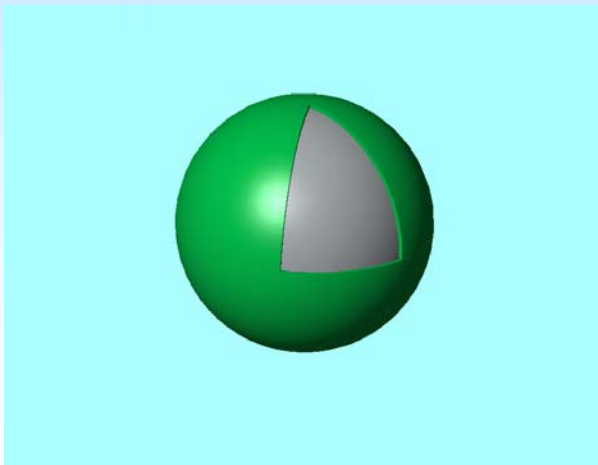
Thick film



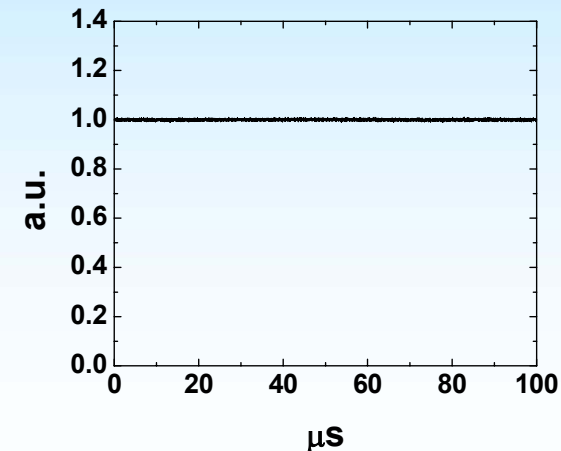
Pulsation Operation



Thin film



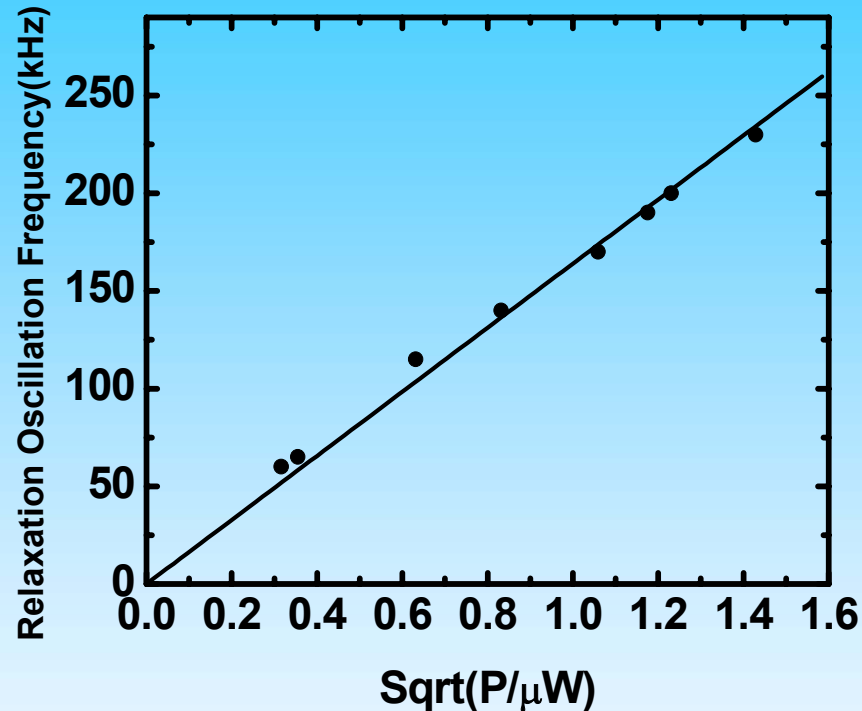
CW Operation



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Relaxation Oscillation vs. Laser Output Power

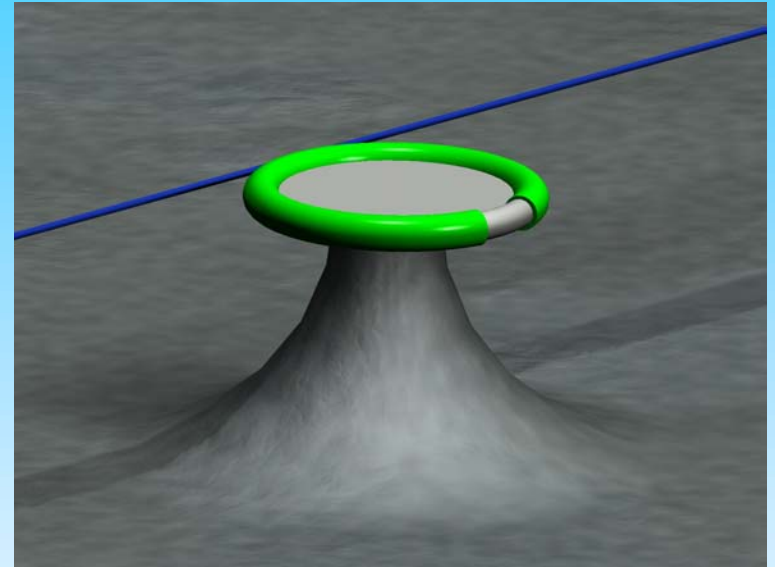
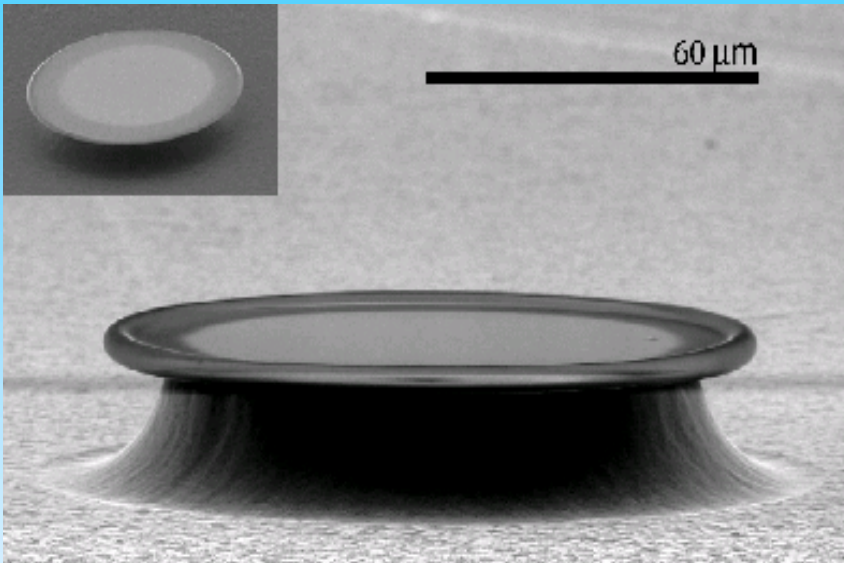


- Sphere diameter is 60- μm ; doped sol-gel shell thickness is 5- μm
- Relaxation oscillation frequency has a linear relationship with the square root of the laser output power

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Future Work



● Surface functionalized microtoroid cavity →
Microlaser on a chip

"Ultra-high-Q toroid microcavity on a chip", *Deniz Armani, Tobias Kippenberg, Sean Spillane and Kerry Vahala*, Nature, Vol. 421, 925-929, 2003

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Summary

- **Low threshold surface gain functionalized silica microsphere lasers are achieved***
- **By varying the thicknesses of the doped sol-gel layer, we can alternate between:**
 - ❖ **Pulsed operation**
 - ❖ **CW operation**
- **Future work: surface functionalize microcavity on a chip**

**Lan Yang and Kerry Vahala Optics Letters, vol. 28, No. 8, 592-594*

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***Presentation will be available at
<http://www.its.caltech.edu/~vahalagr>***

Thanks for you attention!

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